



Form PTO-1449

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PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
30-5000-(4015)-Div2SERIAL NO.  
09/784,233LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Shozo Nagano et al.

#15

FILING DATE  
February 14, 2001GROUP  
1742

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>B</i>	AA	4,189,084	02-1980	Johnson et al.	228	123	
<i>B</i>	AB	4,786,469	11-1988	Weber et al.	420	469	
<i>B</i>	AC	5,590,389	12-1996	Dunlop et al.	419	67	
	AD	<del>09/556,488</del>		J. Kardokus (Amendment dated 7-10-01)			<del>04-21-2000</del>
	AE	<del>09/714,714</del>		J. Kardokus (Amendment dated 5-22-02)			<del>11-15-2000</del>
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

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## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
<i>B</i>	AL	85104006	01-1986	China (abstract)				
<i>B</i>	AM	62036798	08-1987	Japan (abstract)				
<i>B</i>	AN	61227972	10-1986	Japan (abstract)				
<i>B</i>	AO	49007777	02-1974	Japan (abstract)				
	AP							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

<i>B</i>	AR		Reda et al., "Amorphous copper-silver films with high stability", Int. Cent. Theor. Phys., Trieste, Italy, 1983. (Abstract only) The year is sufficiently early so that the month is not in issue.
<i>B</i>	AS		U.S. Copending application 09/556,488, S. Kardokus, filed 4/21/2000
<i>B</i>	AT		U.S. Copending application 09/714,714, S. Kardokus, filed 4/21/00

EXAMINER

S. IP

DATE CONSIDERED

1/12/03

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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